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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* None AICS

\*\* FOREIGN APPLICATIONS \*\*\*\*\* Yes AICS  
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IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Asst. Minna Sarhan</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 13	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 3
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TITLE  
 Method for forming a metal silicide layer in a semiconductor device

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